

	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/822,055	KIM ET AL.	
ſ	Examiner	Art Unit	
	Michael P. Stafira	2877	

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
	d See East n Report	2/20/2007	MPS	

SEARCH (INCLUDING SEAR	NOTES CH STRATEGY)
	DATE	EXMR
East	2/20/2007	MPS
NPL	2/20/2007	MPS
PLUS	2/20/2007	MPS
356/237.1-237.5	2/20/2007	MPS
356/entire subclass	2/20/2007	MPS
entire class/subclass	2/20/2007	MPS